



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yong-kyu LEE, et al.

Art Unit: 2812

Serial No. 10/781,761

Examiner:

Filed: February 20, 2004

Confirmation No. 3739

For: METHOD OF MANUFACTURING TWO-ONO-
TYPE SONOS MEMORY USING REVERSE-
SELF-ALIGNMENT PROCESS

INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. §1.56

Commissioner for Patents
Alexandria, VA 22313-1450

Sir:

Submitted herewith on Form PTO/SB/08 (or PTO-1449, *modified*) is a listing of a document(s) known to applicant in order to comply with applicant's duty of disclosure pursuant to 37 C.F.R. §1.56.

☐ A copy of each listed document is being submitted to comply with the provisions of 37 C.F.R. §§1.97 & 1.98. [Box checked if applicable.]

☒ A copy of each listed non-U.S. patent and/or patent publication and cited literature is being submitted to comply with the provisions of 37 C.F.R. §§1.97 & 1.98. Cited U.S. patents and patent publications are *not* attached in accordance with the waiver set forth in the Notice by the Deputy Commissioner for Patent Examination Policy dated July 11, 2003, applicable to applications having a U.S. filing date *after* June 30, 2003. [Box checked if applicable.]

* * *

The submission of any document herewith, which is not a statutory bar, is not intended as an admission that such document constitutes prior art against the claims of the present application. Applicant does not waive any rights to take any action that would be appropriate to

antedate or otherwise remove as a competent reference any document which is determined to be a *prima facie* prior art reference against the claims of the present application.

☒ The listed document(s) is/are being submitted in compliance with 37 C.F.R. 1.97(b)(3): submission before the mailing date of the first action on the merits. [Box checked if applicable.]

☐ The foregoing document came to applicant's attention during the prosecution of their corresponding _____ application. ☐ A copy of the _____ Search Report is also attached. [Box(es) checked if applicable.]

CERTIFICATION

☐ The undersigned hereby certifies in accordance with 37 CFR §1.97(e)(1) that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three (3) months prior to the filing of this Statement. [Box checked if applicable.]

* * *

Applicant respectfully requests that the listed document(s) be considered by the Examiner and be made of record in the present application and that an initialed copy of Form PTO/SB/08 be returned in accordance with MPEP §609.

* * *

FEE PAYMENT

☐ The fee mandated by 37 C.F.R. §1.17(p) is believed applicable. [Box checked if applicable.]

☐ Attached is a check in payment of this fee (\$180.00). [Box checked if applicable.]

☐ This fee may be charged to Deposit Account No. 50-1645. (A duplicate copy of this paper is enclosed.) [Box checked if applicable.]

* * *

Also enclosed is a copy of a publication authored by inventors herein:


Lee, et al., "TWIN-BIT SILICON-OXIDE-NITRIDE-OXIDE-SILICON(SONOS) MEMORY BY INVERTED SIDEWALL PATTERNING (TSM-ISP)", Digest of Technical Papers, 2003 Annual Research Report, Semiconductor Materials & Devices Laboratory, School of Electrical Engineering, Seoul National University, Seoul, Korea February 21-22, 2003.

This reference, having an effective date of February 21, 2003, does not qualify as prior art under the statute.

Respectfully submitted,

July 29, 2004

Date


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DEPOSIT ACCOUNT CHARGE AUTHORIZATION

If fee payment is enclosed, this amount is believed to be correct. However, the Director is hereby authorized to charge any deficiency or credit any overpayment to Deposit Account No. 50-1645.

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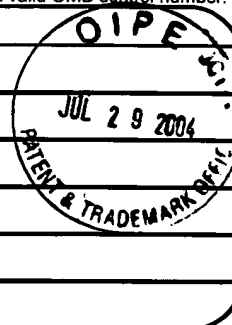
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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

Complete if Known

| | |
|------------------------|----------------------|
| Application Number | 10/781,761 |
| Filing Date | February 20, 2004 |
| First Named Inventor | Yong-kyu LEE, et al. |
| Art Unit | 2812 |
| Examiner Name | |
| Attorney Docket Number | 249/402 |



Sheet

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of

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NON PATENT LITERATURE DOCUMENTS

| Examiner Initials* | Cite No. ¹ | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. | T ² |
|-----------------------|--------------------------|---|----------------|
| | | LUSKY, et al, Entitled*, IEEE Electron Device Letters, 23(9):556-558, (September 2002) | |
| | | *Electrons Retention Model for Localized Charge in Oxide-Nitride-Oxide (ONO) Dielectric" | |
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Examiner
SignatureDate
Considered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 120 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, Washington, DC 20231.

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